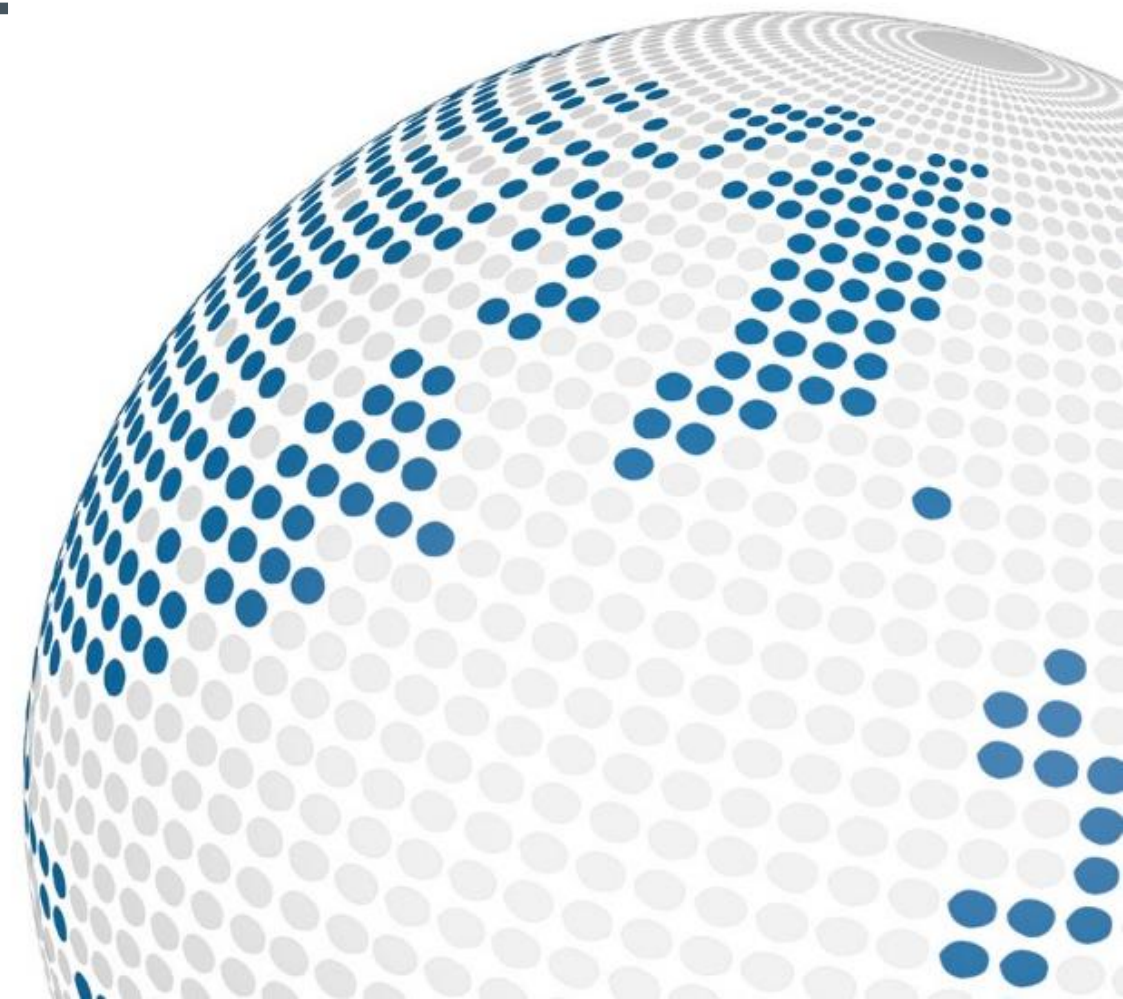


# Multizone, Multiobject D-TOF System in 55nm

ams AG - Shaping the world with sensor solutions

Robert Kappel  
1<sup>st</sup> International SPAD Sensor Workshop  
Les Diablerets, Feb 27<sup>th</sup>, 2018



# Content

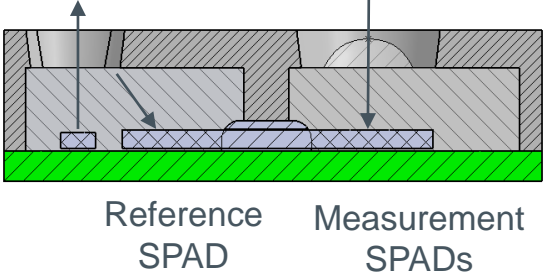
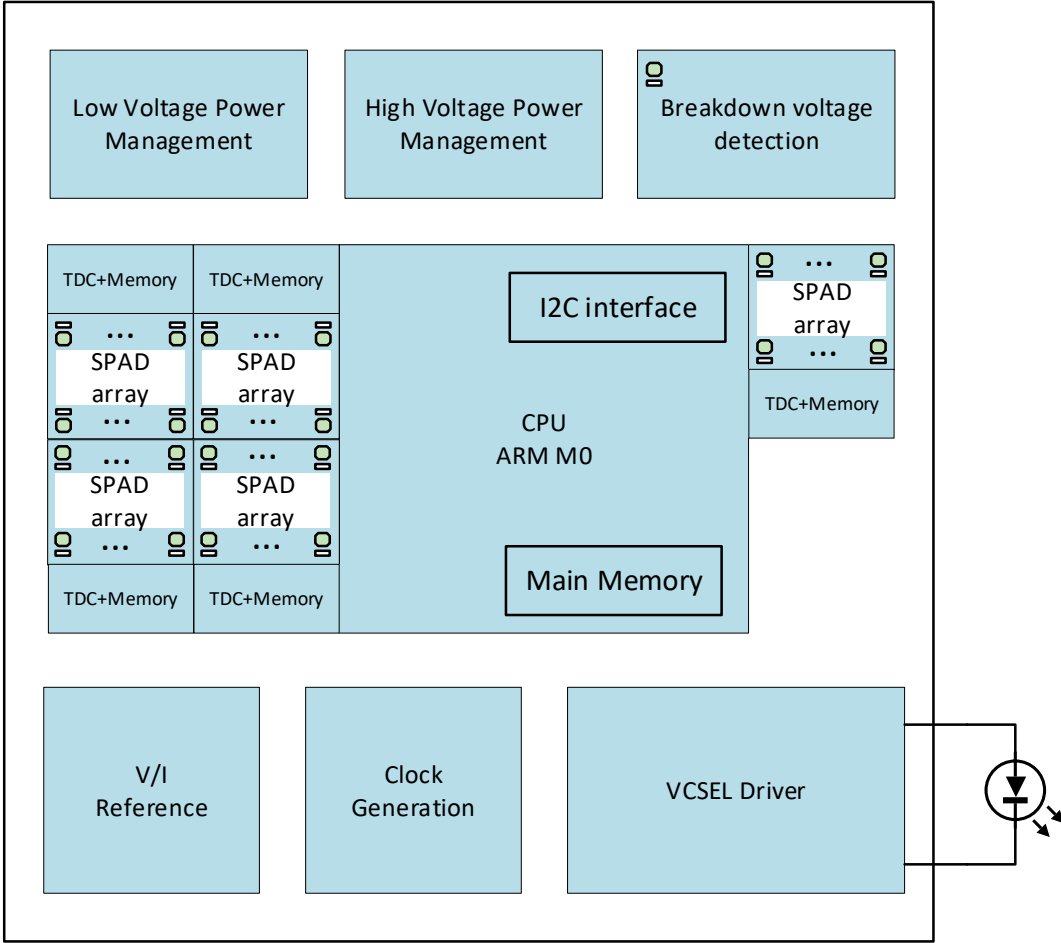
- Time of flight module
  - Silicon
    - » Sensor
      - SPAD
      - Readout
      - Time to Digital Converter
      - Data storage
    - » Illumination
      - VCSEL driver
- Measurement Results
  - VCSEL beam
  - Distance measurement
    - » Module only, cover glass, smudge
- Demonstration video
  - » Distance measurement
  - » Multi object
  - » Multi zone

# D-TOF Silicon

## SPAD sensor and light emitter

- Architecture
- Characterization data

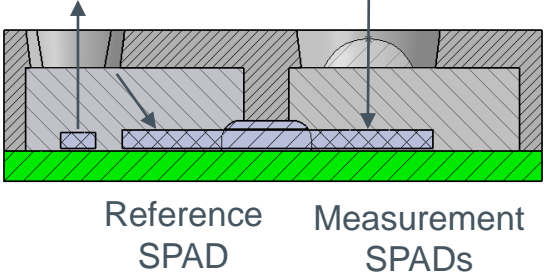
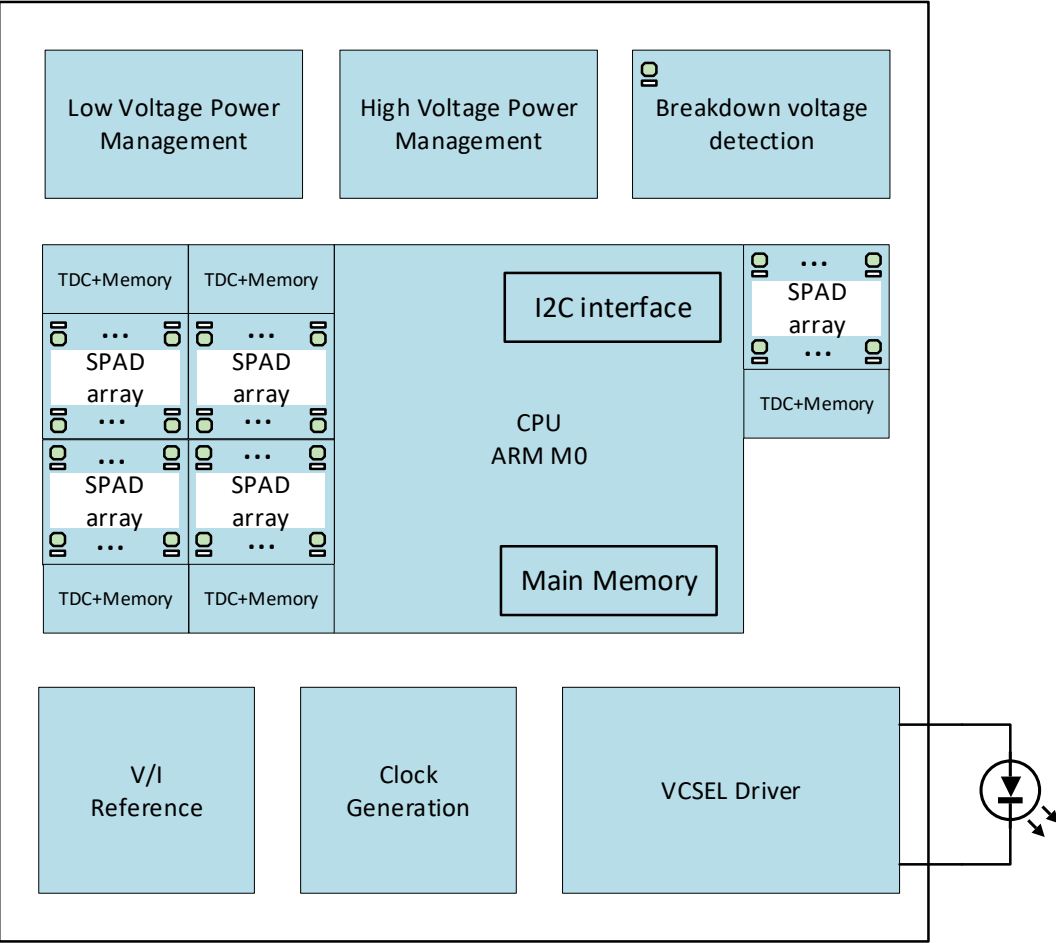
# Block Diagram



### Features:

- 55nm HV process node
- Custom developed SPAD sensor
- 4 zones on main sensor array
- TDC and histogram based distance detection
- Fully integrated power management
- Cortex M0 CPU
- Sub-ns pulse generating laser driver
- Multi-mesa VCSEL diode

# Block Diagram

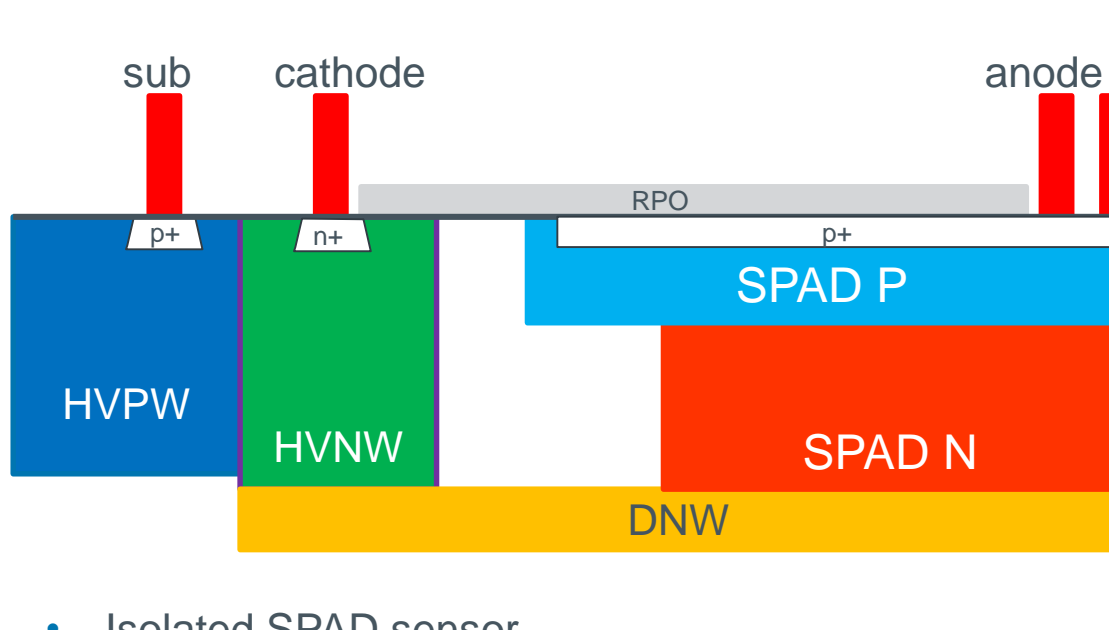


### Features:

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- Custom developed SPAD sensor
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- TDC and histogram based distance detection
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- Sub-ns pulse generating laser driver
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# SPAD Details

## SPAD cross section:



## SPAD characteristics:

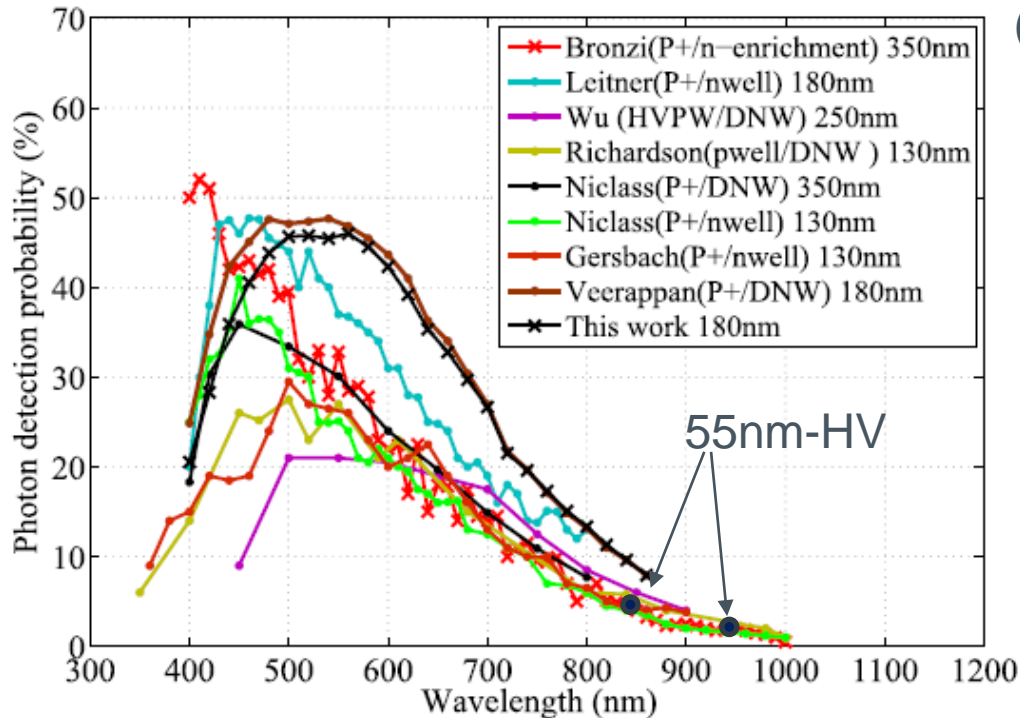
Parameter	Typ	Unit
BV	17.7	V
BV temperature coefficient	0.016	V/K
DCR @ 3V	0.28	cps/um <sup>2</sup>
PDP @ 940nm	1.5	%
Timing Jitter @ 940nm (FWHM)	80	ps
After pulsing probability	<0.5	%
Fill factor (SPAD + Quenching)	25	%

- Isolated SPAD sensor
- Modified process to generate SPAD P and SPAD N layer to reduce the breakdown voltage
  - + low DCR
  - + low jitter
  - + Low afterpulsing probability

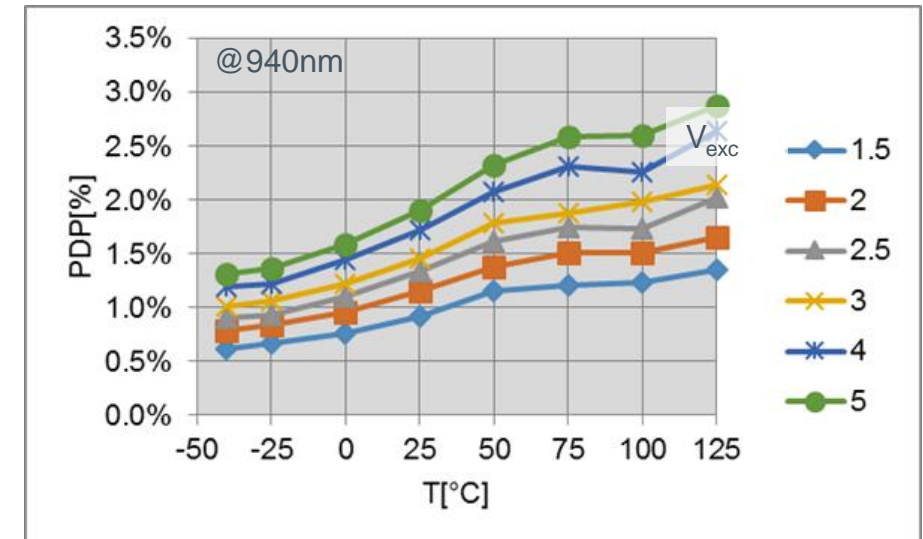
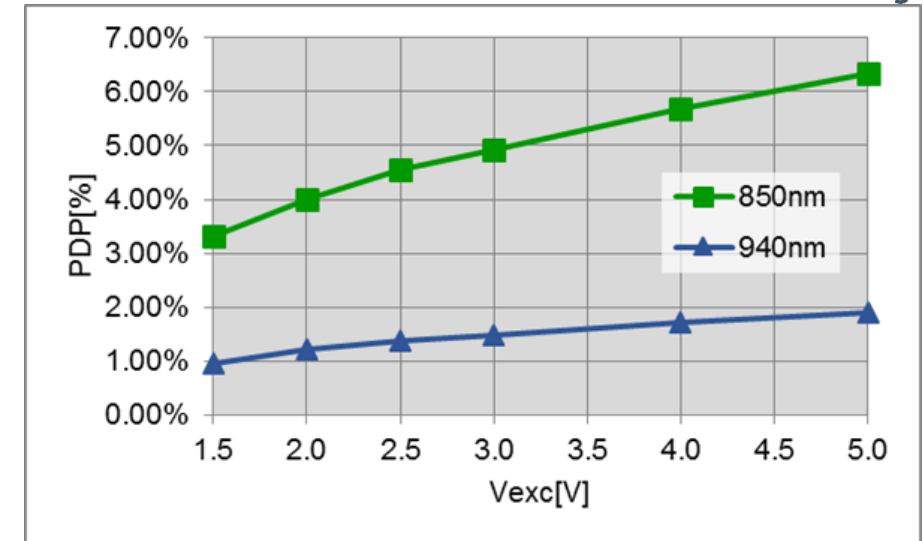
# SPAD Key Characteristics

$$PDP = f(V_{exc}, T, \lambda)$$

- Photon detection probability PDP depends on wavelength and excess bias voltage.
- PDP increases with temperature for 940nm because bandgap decreases with temperature.
- PDP similar to state of the art.



(†)



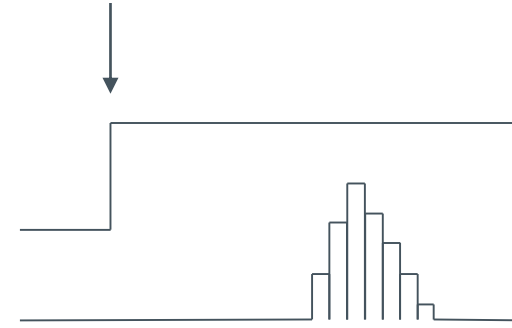
(†) Veerappan, C., Charbon, E., "A Low Dark Count p-i-n Diode Based SPAD in CMOS Technology," IEEE Trans. Electron Devices 63(1), 65–71 (2016).

# SPAD Key Characteristics

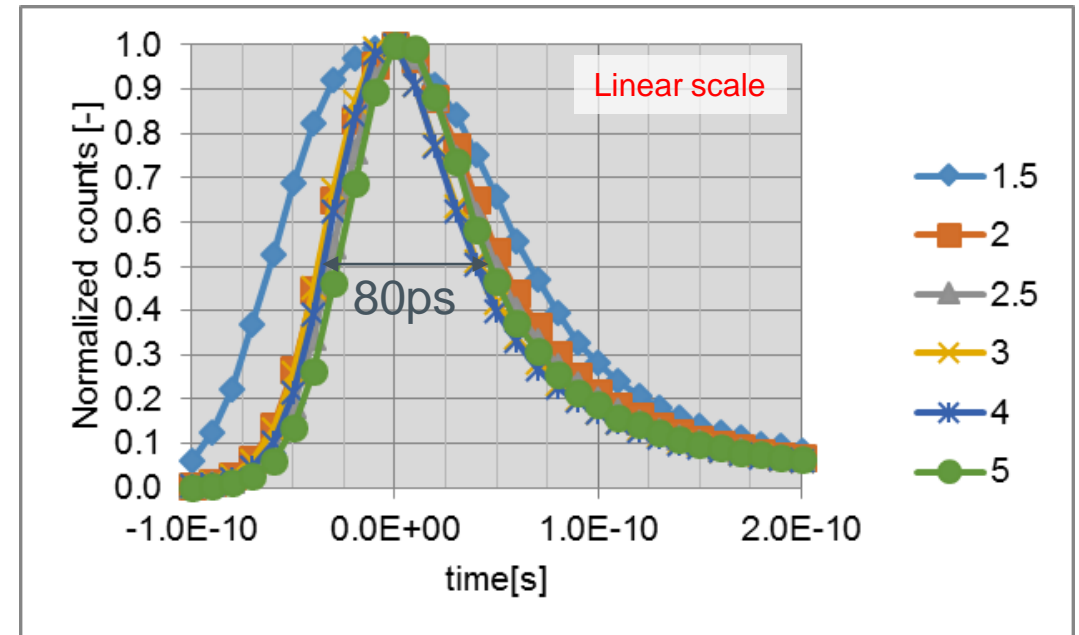
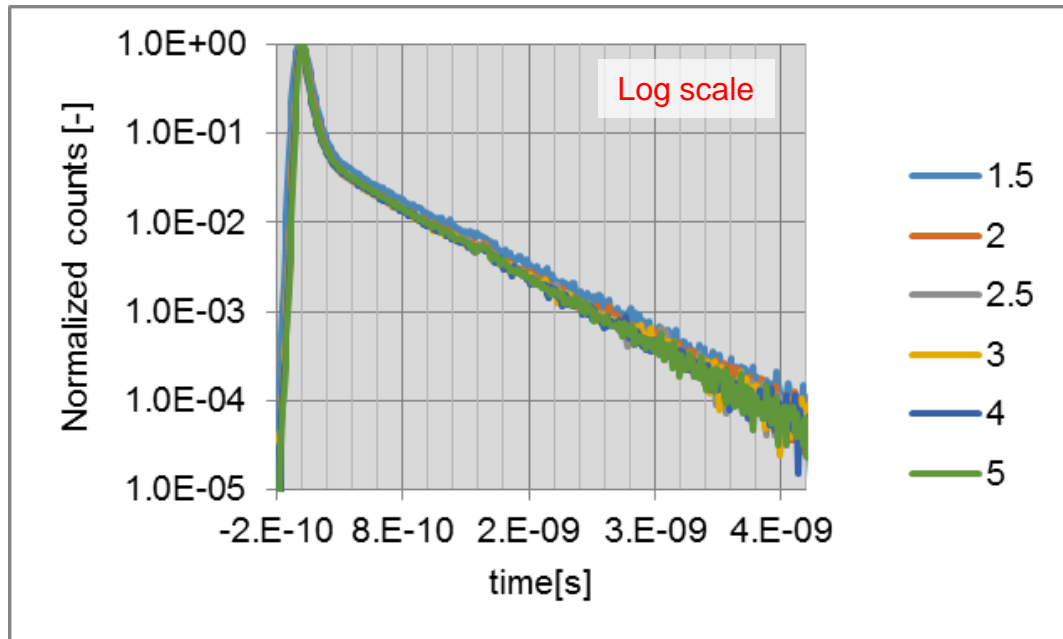
## Timing Jitter @940nm

- The full width half maximum (FWHM) of the timing jitter decreases with excess bias voltage.
- The jitter tail is hardly impacted by the excess bias voltage.
- The FWHM at 3V excess bias voltage is 80ps including the jitter from the Laser source (42ps).

Sync pulse of laser



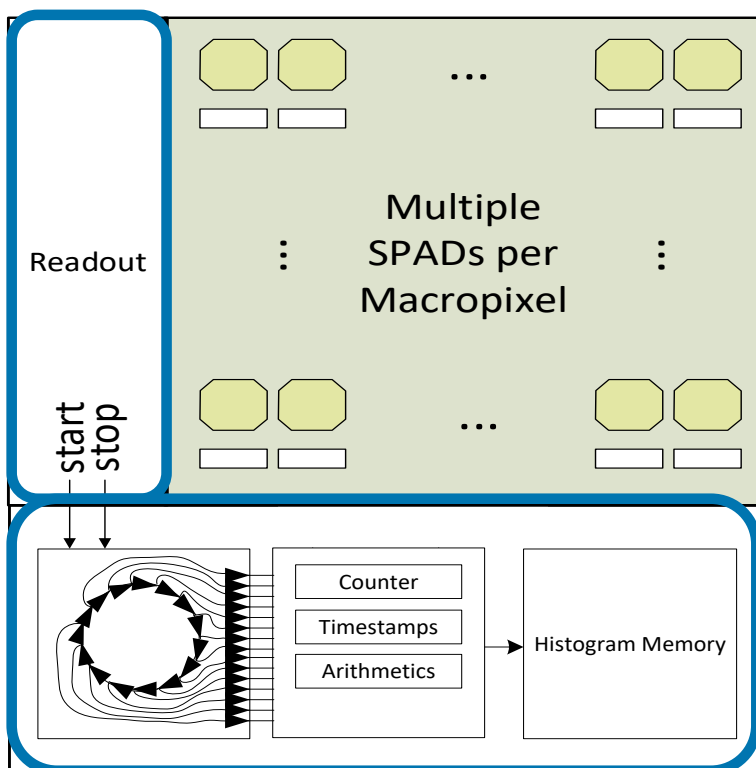
Histogram of accumulated event edges





# Distance Measurement

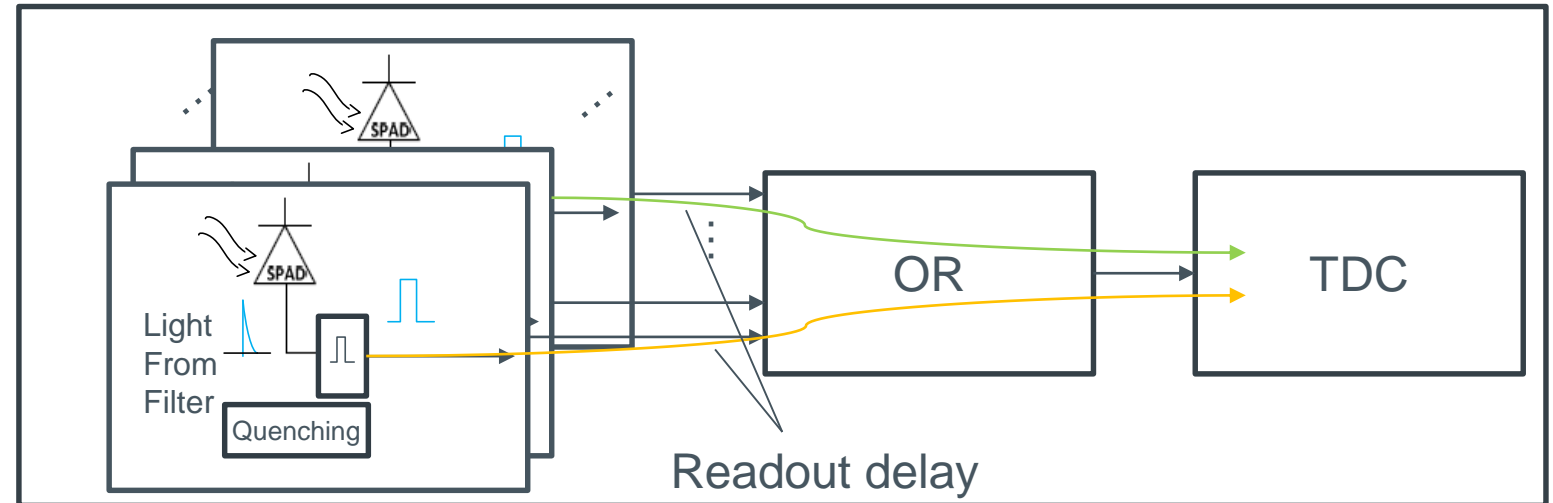
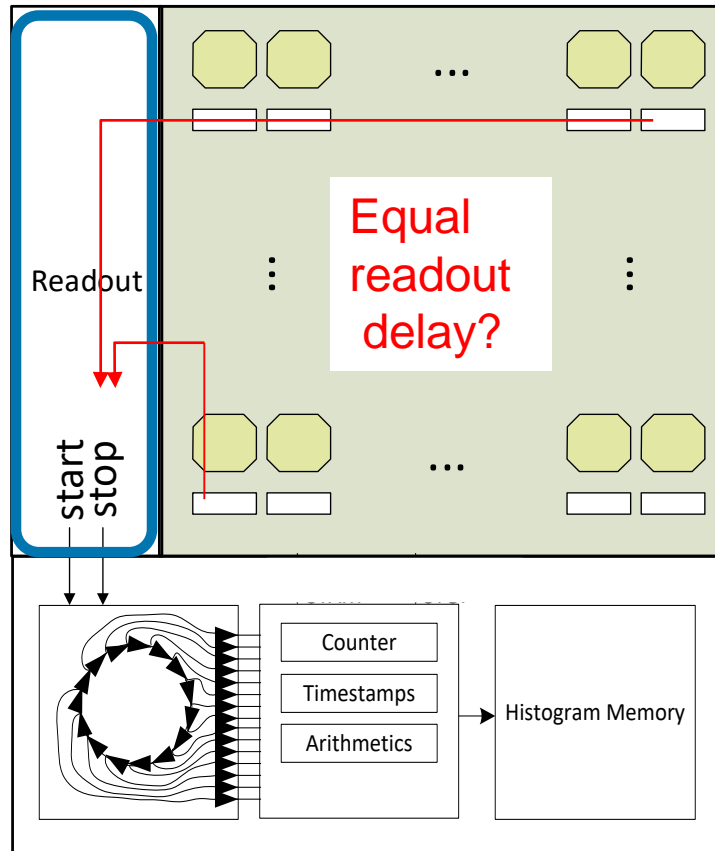
## Readout and Time-to-Digital converter



- SPAD readout circuitry
- Symmetrical digital gates
  - TDC principle
  - TDC architecture
- Distance processing and calibration
  - Histogram storage

# Sensor Readout

## Overview

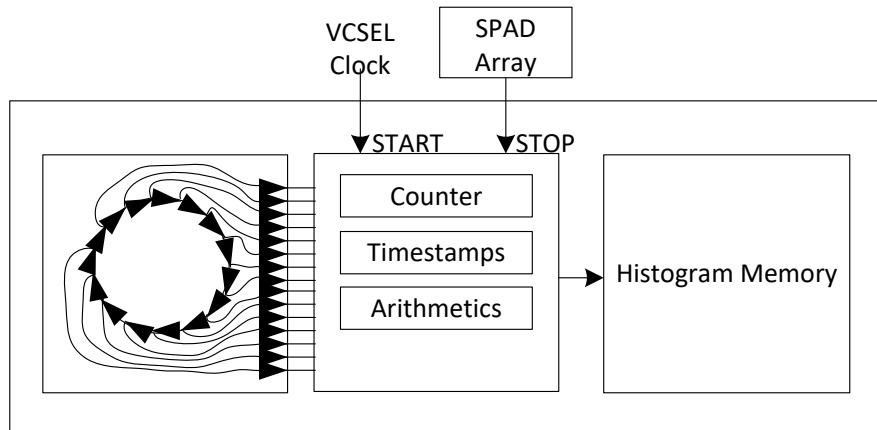


- Pulse shaper to generate a narrow event pulse independent on SPAD deadtime
- Multiple SPADs to be combined to a single TDC channel by using an OR-Tree
- Readout time must be equal from each SPAD to the TDC

# Time to Digital Converter

## Overview

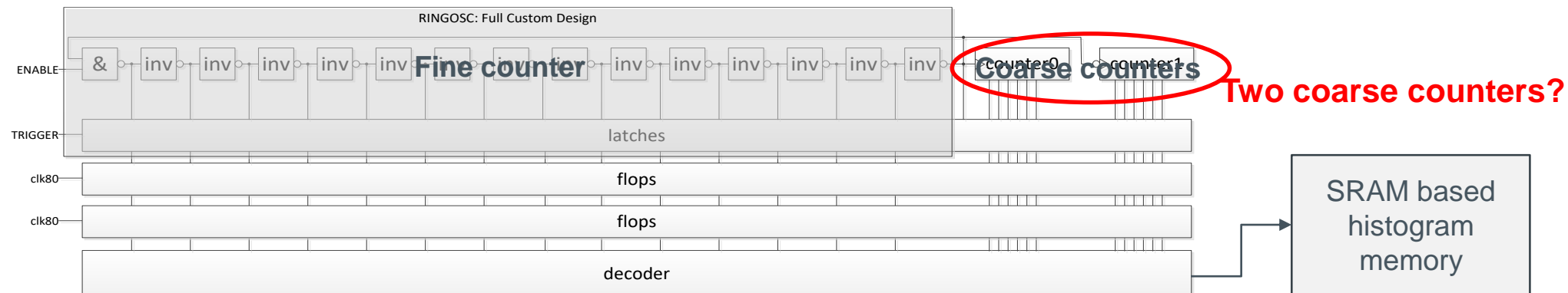
Time resolving unit of sensor:



Free running ring oscillator with flip-flop based overflow counter and latches

- Fine Counter:
  - LSB represents propagation delay of inverting cell (~50ps)
- Coarse Counter:
  - Flip-flop based counter detecting overflow of fine counter
- Latch:
  - To store the actual state of the counter on-the-fly without disturbing oscillation
- Decoder: decode
  - Combines fine- and coarse- counter value to a timestamp
- Data is stored in SRAM based histogram memory
  - » Counter value represent address to be incremented

TDC core architecture:



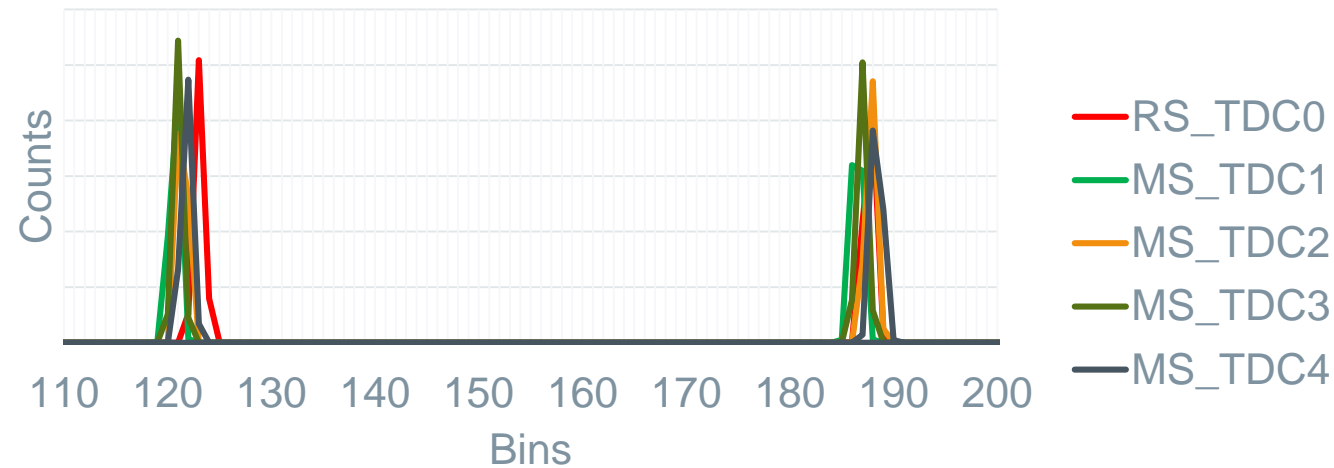




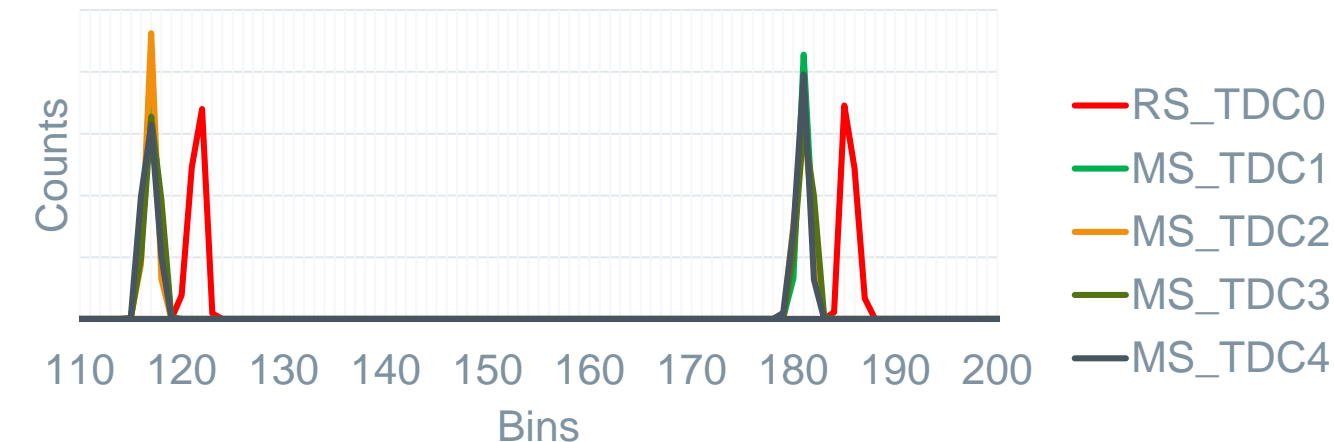
# TDC Calibration

## Digital Calibration Scheme

### Before calibration



### After calibration



- Each TDC contains one ring oscillator
  - Absolute ring oscillator speed is unknown (-50%..+100%)
  - Relative ring oscillator speed amongst each other (+-5%)
- Pure digital solution for calibration is used.
  - Each TDC is able to measure its own ring oscillator speed using the system clock as reference.
  - Correction factor can be determined for individual histograms

# Illumination of scene

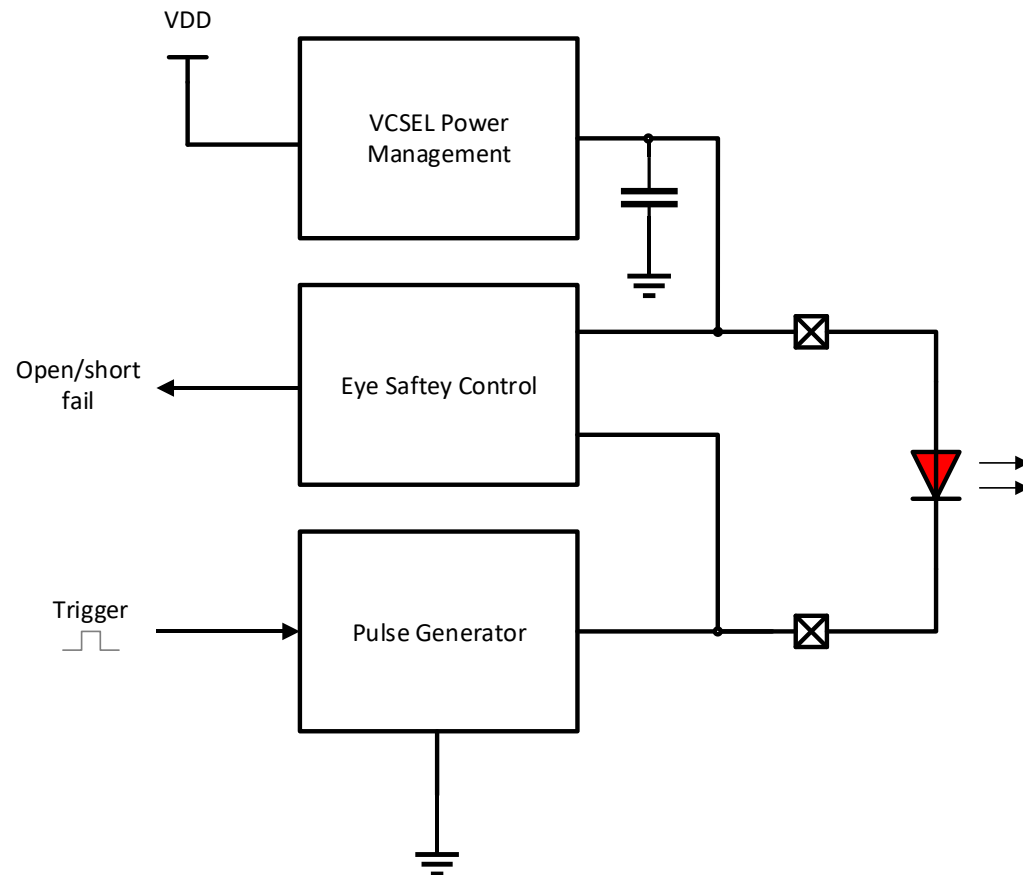
## VCSEL and VCSEL Driver

- VCSEL architecture
  - VCSEL driver
- Optical characteristics of beam

# VCSEL Driver

## Key Performance Parameter

### Block Diagram



- Charge Pump
  - Decouples min supply voltage from VCSEL forward voltage
  - Small loop of VCSEL current (low EMI)
  - No extra PMOS switch required
- Eye Safety Control
  - Short on VCSEL anode/cathode
  - Current limitation through VCSEL (charge pump)
  - Clock failure detection (charge pump)
- Pulse generation
  - Pulse width: ~300ps FWHM
  - High peak current
- Laser safety: Class 1



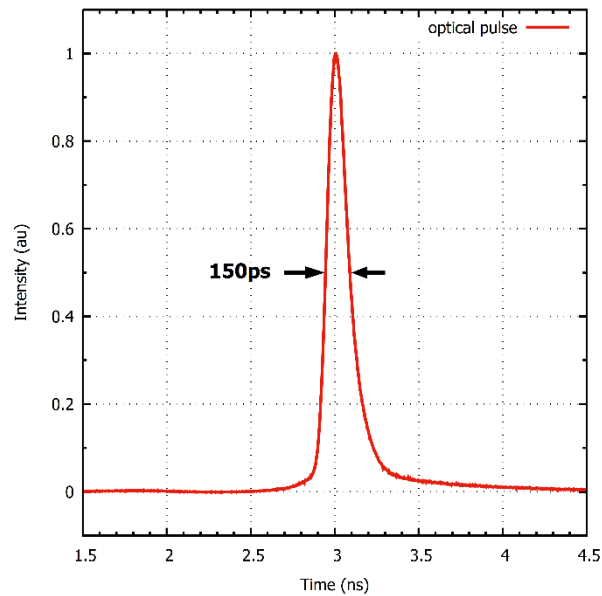
# System performance

## Measurement results

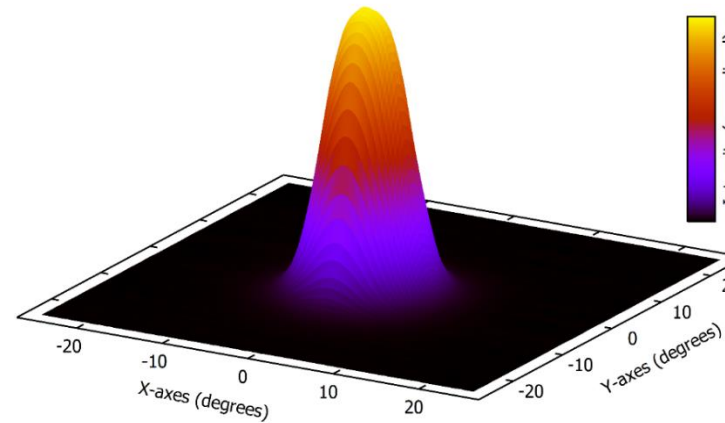
- VCSEL pulse
- Crosstalk and smudge removal
- High accuracy, Independent of object color
  - Demonstration video

# VCSEL beam measurements

## Optical pulse



## VCSEL emission profile



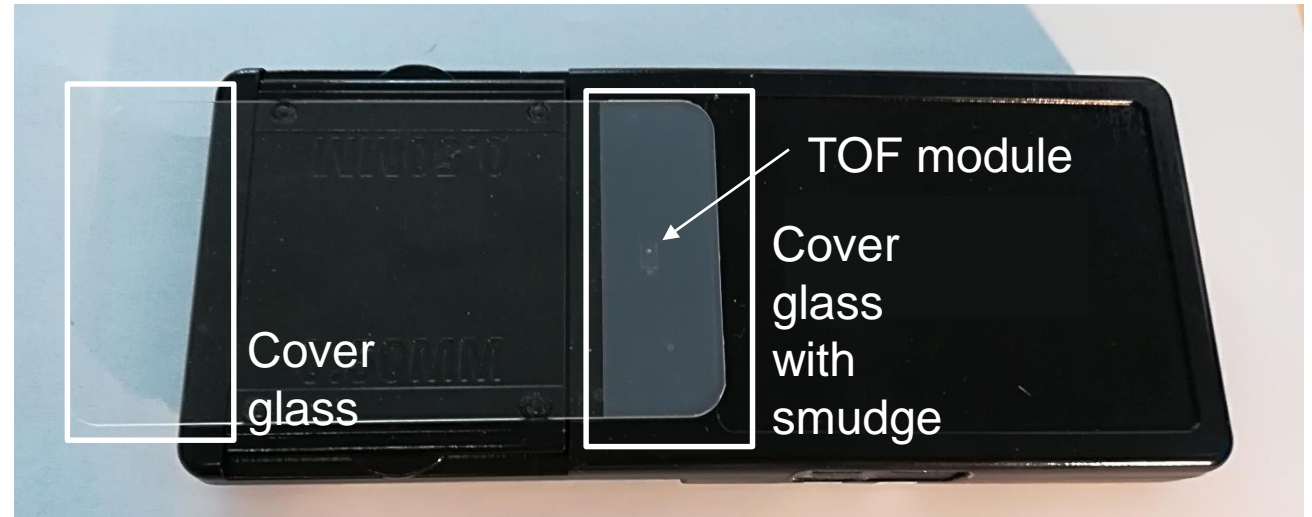
### Characteristics:

- Optical pulse 150ps
- FOI 15° (1/e<sup>2</sup>)
- Sub-ns pulsed mode allows increased peak power

# Measurement conditions

## 200mm to 3000mm in 50mm steps

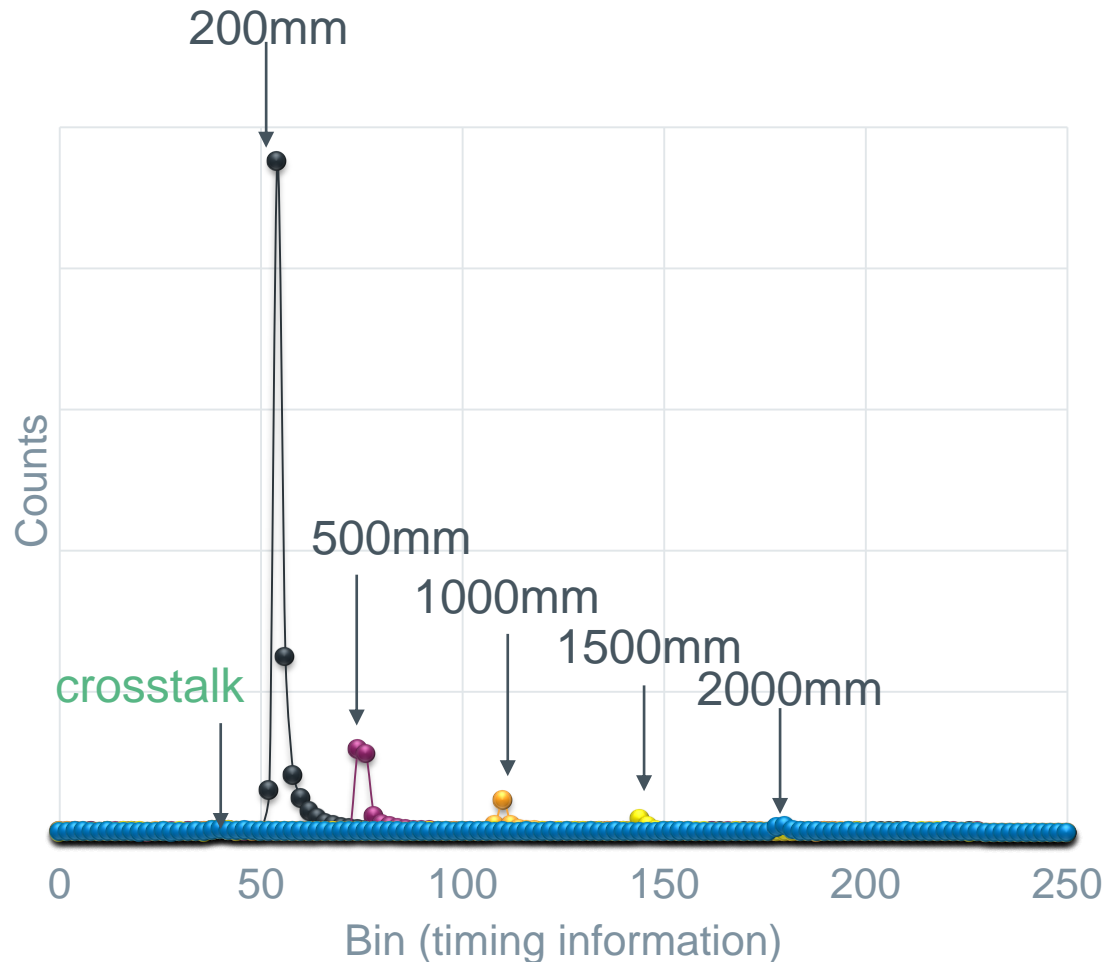
- Target size:
  - 1m x 1m
  - 50fps/800 000 integration cycles
- Color:
  - 90% white
  - 18% grey
  - 4% black
- Conditions:
  - Without cover glass
  - With cover glass (85% transmissivity)
  - Cover glass + smudge
- Background light on the target:
  - 0.2klux
  - 1klux
  - 5klux
  - 10klux
  - 20klux



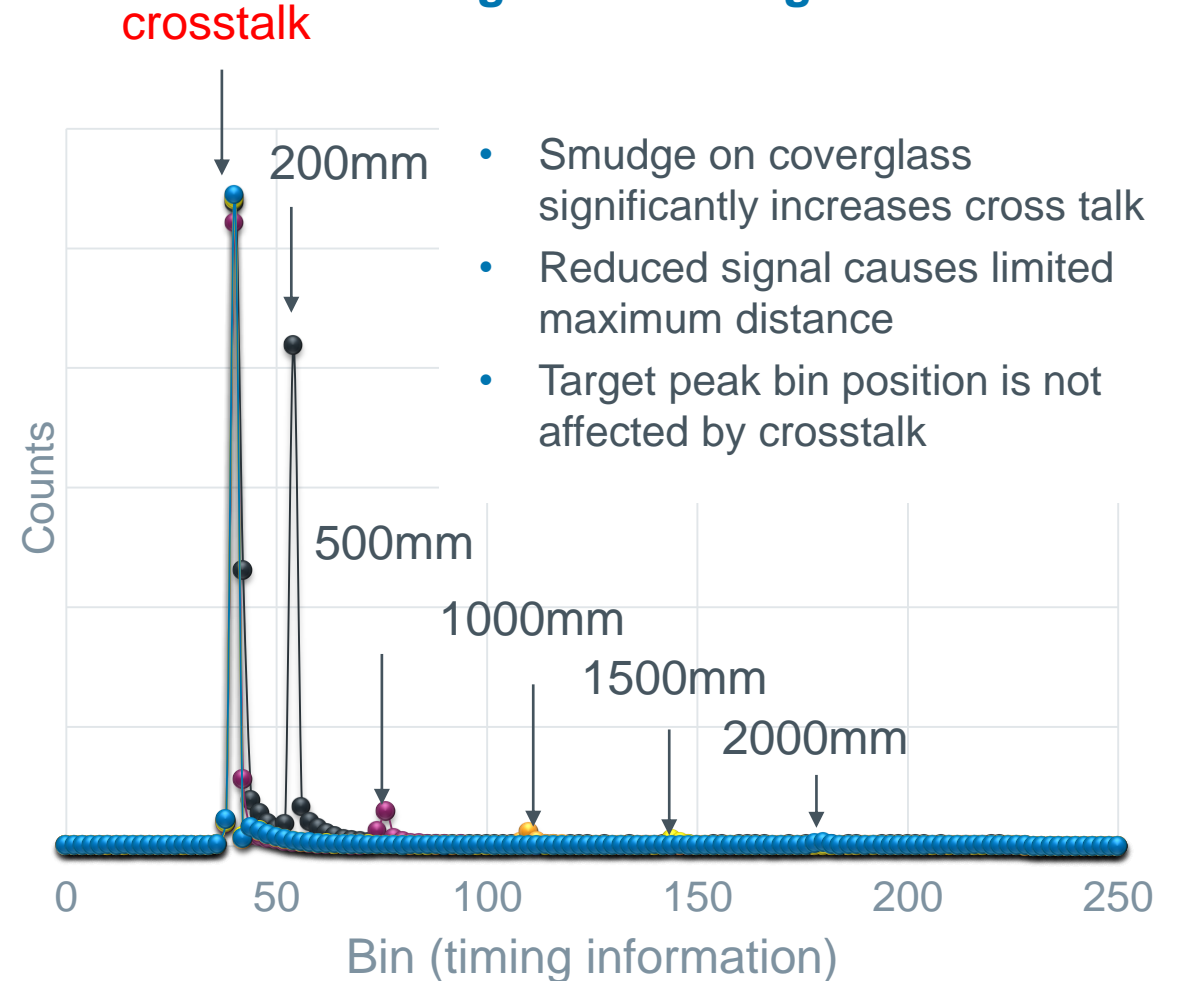
# Histogram comparison

without background light

without Coverglass



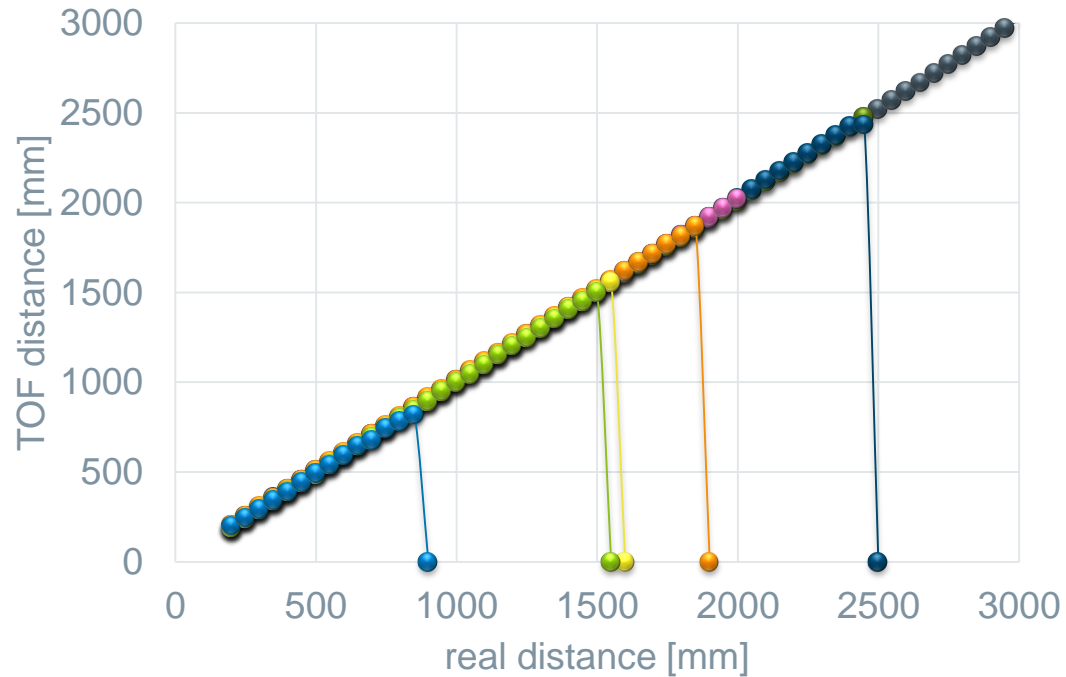
Coverglass + smudge



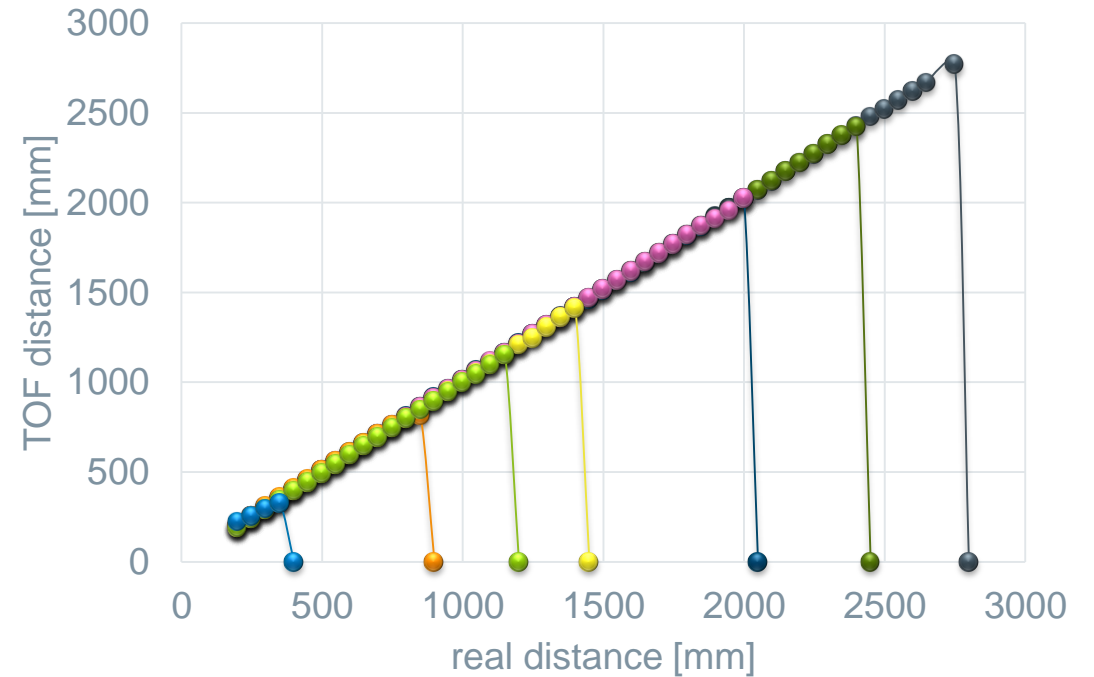
# Distance measurement I

## 0.2klux and 1klux

0.2klux



1klux



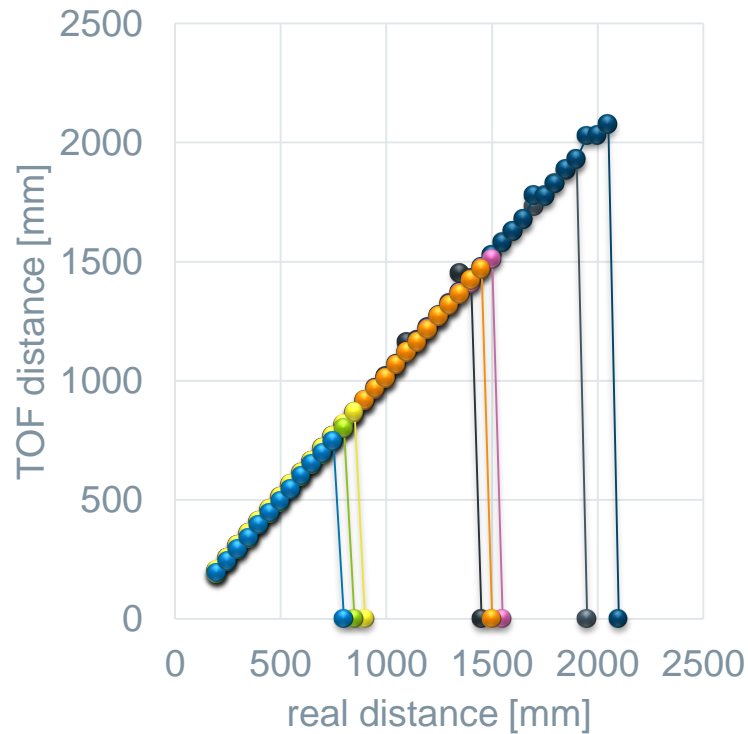
- white\_0.2klux\_noCG
- white\_0.2klux\_Cgsmudge
- grey\_0.2klux\_noCG
- grey\_0.2klux\_Cgsmudge
- grey\_0.2klux\_CG
- black\_0.2klux\_noCG
- black\_0.2klux\_CG
- black\_0.2klux\_Cgsmudge
- white\_0.2klux\_CG
- black\_0.2klux\_CG

- white\_1klux\_noCG
- white\_1klux\_Cgsmudge
- grey\_1klux\_noCG
- grey\_1klux\_Cgsmudge
- grey\_1klux\_CG
- black\_1klux\_noCG
- black\_1klux\_CG
- black\_1klux\_Cgsmudge
- white\_1klux\_CG
- black\_1klux\_CG

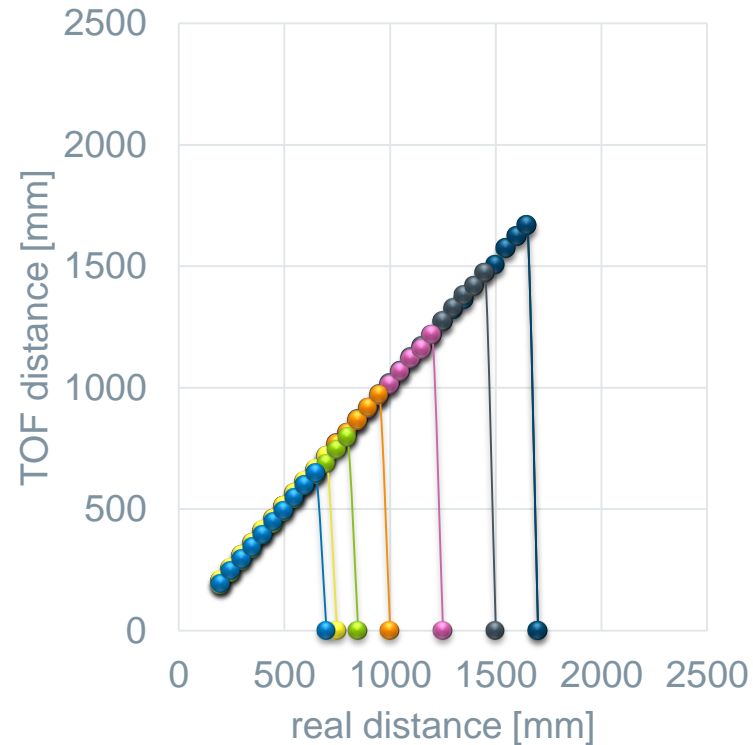
# Distance measurement II

5klux, 10klux and 20klux

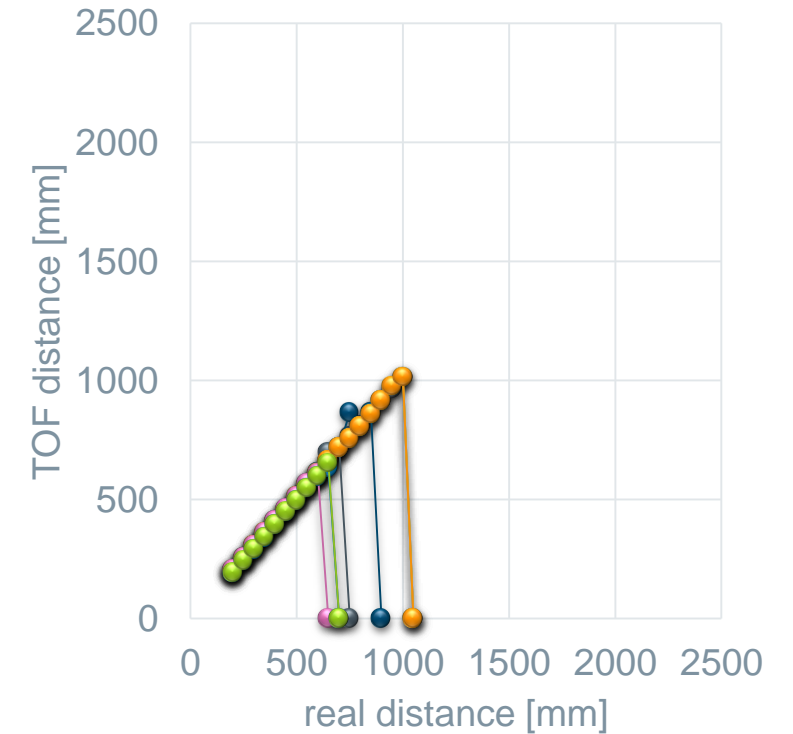
5klux



10klux



20klux



- white\_5klux\_noCG      ● white\_5klux\_CG
- white\_5klux\_Cgsmudge      ● grey\_5klux\_noCG
- grey\_5klux\_CG      ● grey\_5klux\_Cgsmudge
- black\_5klux\_noCG      ● black\_5klux\_CG

- white\_10klux\_noCG      ● white\_10klux\_CG
- white\_10klux\_Cgsmudge      ● grey\_10klux\_noCG
- grey\_10klux\_CG      ● grey\_10klux\_Cgsmudge
- black\_10klux\_noCG      ● black\_10klux\_CG

- white\_20klux\_noCG      ● white\_20klux\_CG
- white\_20klux\_Cgsmudge      ● grey\_20klux\_noCG
- grey\_20klux\_CG      ● grey\_20klux\_Cgsmudge
- black\_20klux\_noCG      ● black\_20klux\_CG

# Conclusion

- Direct Time of Flight system using robust histogram-based architecture
- Custom developed SPAD sensor in 55nmHV process node
- Symmetrical readout structure
- Free running TDC architecture
  - Digital calibration scheme
  - Double differential measurement principle
- 940nm VCSEL laser in pulsed operation
  - Laser class 1 safe
- Distance measurement over a wide range of conditions
  - Distance measurement insensitive to crosstalk and smudge
- Multi-object
- Multi-zone capability



# Thank you!

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